## Application/Control No. Applicant(s)/Patent Under Reexamination 10/053,701 IWASE ET AL. Notice of References Cited Art Unit Examiner Page 1 of 1 David Y. Chung 2871 **U.S. PATENT DOCUMENTS Document Number** Date Classification Name Country Code-Number-Kind Code MM-YYYY 313/506 Α US-6,624,570 09-2003 Nishio et al. В US-С US-US-D US-Ε F US-US-G US-Н

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	S					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	٧	
	w	
	x	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

US-

US-

US-US-

US-

J

Κ

L

М